

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR
 Subject Matter:: UTILITY
 CD-ROM or CD-R?: NONE
 Title:: MICROLITHOGRAPHY METHOD USING
 A MASK WITH CURVED SURFACE
 Attorney Docket Number:: 287990US2PCT
 Total Drawing Sheets:: 4

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
 Primary Citizenship Country:: France
 Status:: FULL CAPACITY
 Given Name:: Jean-Charles
 Family Name:: GUIBERT
 City of Residence:: SAINT ETIENNE DE CROSSEY
 Country of Residence:: France
 Street of Mailing Address:: 4 Beau Rivoire
 City of Mailing Address:: SAINT ETIENNE DE CROSSEY
 Country of Mailing Address:: France
 Postal or Zip Code of Mailing Address:: F-38960

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/FR04/50433	09/15/04

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
03 50561	France	09/17/03	YES

ASSIGNMENT INFORMATION

Assignee Name::	COMMISSARIAT A L'ENERGIE ATOMIQUE
Street of Mailing Address::	31-33 rue de la Federation
City of Mailing Address::	Paris 15 ème
Country of Mailing Address::	France
Postal or Zip Code of Mailing Address::	F-75752